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## APPLICANTS

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## \*\* CONTINUING DATA

*MK (verified)*

This application is a CON of 09/764,523 01/18/2001 PAT 6,736,147  
 which claims benefit of 60/176,592 01/18/2000

## \*\* FOREIGN APPLICATIONS

*MK (NONE)*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/21/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	5	22	3
Examiner's Signature <i>info</i> Initials <i>MK</i>				

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## TITLE

Semiconductor processing with a remote plasma source for self-cleaning

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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